AF/1752



RESPONSE UNDER 37 C.F.R. 1.116 - EXPEDITED PROCEDURE - EXAMINING GROUP 1752

PATENT

mey Docket No. 5576-125

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Kubota et al.

Serial No.: 09/851,274

Filed: May 8, 2001

For:

DEGLET MATERIAL AND

Examiner: Lee, Sin J.

Confirmation No.: 3436

RESIST MATERIAL AND METHOD FOR PATTERN FORMATION

March 18, 2003

Art Unit: 1752

Commissioner for Patents Washington, DC 20231

AMENDMENT AFTER FINAL

Sir

This Amendment is responsive to the final Office Action mailed January 22, 2003. Applicants respectfully request entry of this Amendment and allowance of the present application. A marked-up version of the claims showing changes made to the claims is attached hereto and is entitled "Version With Markings To Show Changes Made."

In the Claims:

Please replace Claim 9 with the following amended claim.

9. (Amended) A resist material according to claim 1 wherein said one or more surfactants having a fluorine substituent is selected from the group consisting of perfluoroalkylpolyoxyethylene ethanol, fluorinated alkyl ester, perfluoroalkylamine oxide, perfluoroalkylethylene oxide adduct, and fluorine-containing organosiloxane compounds.

REMARKS

Applicants appreciate the thorough examination of the present application as evidenced by the final Office Action (Final Action) mailed January 22, 2003. Claims 1-4 and 9-20 are pending in the present application. Claims 1-4 and 9-20 stand rejected under 35 U.S.C. § 103(a) as being unpatentable over the combination of U.S. Patent No. 6,159,656 to Kawabe et al. with U.S. Patent No. 6,174,661 B1 to Chen et al. Claim 9 has been amended to correct a typographical error. Support for the amendment to Claim 9 can be found in Claim 9 as originally presented and in the specification at page 8, lines 13-24, among other places.

The concerns raised by the Examiner are addressed below as set forth in the Final Action.